Terahertz ellipsometry using electronbeam based sources



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Our message

• THz ellipsometry opens a new pathways for the investigation of the properties complex optical materials needed as building blocks for next generation nanoelectronics

• in combination with external magnetic fields THz generalized ellipsometry is a powerful tool to determine free charge carrier properties and study quantum confinement effects in semiconductors and semimetals

• electron beam based sources are readily available (Synchrotron radiation, Smith-Purcell radiation) and offer sufficient radiation in the THz frequency domain

New THz materials preparation and analysis Center at UNL: THeMPAC



Generalized ellipsometry in combination with external magnetic fields:

 Semiconductors: unbound charge carrier resonances in spatially confined structures in the THz frequency domain Highly oriented pyrolytic graphite: Landau level transitions, electron and hole contributions



Motivation: THz spectroscopic ellipsometry

structures: quantum opto-mechanical couplers with Eigenresonances in the THz-IR domain

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 future nanoelectronics will be assembled from nano-sized thin film structures and metamaterials

 new physical phenomena in these building blocks like quantum confinement and surface effects will alter the physical properties and need to be studied

optical metrology tools needed optical and mechanical Eigenresonances of these material fall in the THz domain



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